

**AFRL-DE-PS-
TP-2007-1003**

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Chemical Vapor Composite Silicon Carbide for Space Telescopes (Postprint)

**Clifford Tanaka
Kyle Webb**

18 September 2006

Conference Proceedings

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**AIR FORCE RESEARCH LABORATORY
Directed Energy Directorate
3550 Aberdeen Ave SE
AIR FORCE MATERIEL COMMAND
KIRTLAND AIR FORCE BASE, NM 87117-5776**

REPORT DOCUMENTATION PAGE

*Form Approved
OMB No. 0704-0188*

Public reporting burden for this collection of information is estimated to average 1 hour per response, including the time for reviewing instructions, searching existing data sources, gathering and maintaining the data needed, and completing and reviewing this collection of information. Send comments regarding this burden estimate or any other aspect of this collection of information, including suggestions for reducing this burden to Department of Defense, Washington Headquarters Services, Directorate for Information Operations and Reports (0704-0188), 1215 Jefferson Davis Highway, Suite 1204, Arlington, VA 22202-4302. Respondents should be aware that notwithstanding any other provision of law, no person shall be subject to any penalty for failing to comply with a collection of information if it does not display a currently valid OMB control number. PLEASE DO NOT RETURN YOUR FORM TO THE ABOVE ADDRESS.

1. REPORT DATE (DD-MM-YYYY) 18 September 2006		2. REPORT TYPE Conference Proceedings		3. DATES COVERED (From - To) 24 Mar 05 - 1 Sep 06	
4. TITLE AND SUBTITLE Chemical Vapor Composite Silicon Carbide for Space Telescopes (Postprint)				5a. CONTRACT NUMBER FA9451-05-C-0019	5b. GRANT NUMBER
				5c. PROGRAM ELEMENT NUMBER 65502F	5d. PROJECT NUMBER 3005
				5e. TASK NUMBER DP	5f. WORK UNIT NUMBER FD
7. PERFORMING ORGANIZATION NAME(S) AND ADDRESS(ES)				8. PERFORMING ORGANIZATION REPORT NUMBER	
AFRL/DESE 3550 Aberdeen Avenue SE Kirtland AFB, NM 87117-5776				Trex Enterprises Corporation 3038 Auakele St. Lihue, Kauai HI 96766	
9. SPONSORING / MONITORING AGENCY NAME(S) AND ADDRESS(ES) Air Force Research Laboratory 3550 Aberdeen Ave. SE Kirtland AFB, NM 87117-5776				10. SPONSOR/MONITOR'S ACRONYM(S) AFRL/DESE	
				11. SPONSOR/MONITOR'S REPORT NUMBER(S) AFRL-DE-PS-TP-2007-1003	
12. DISTRIBUTION / AVAILABILITY STATEMENT Approved for Public Release; Distribution is Unlimited.					
13. SUPPLEMENTARY NOTES Published in Mirror Technology Days 2006, Albuquerque, NM, October 18-20, 2006. http://optics.nasa.gov/techdays/index.html . GOVERNMENT PURPOSE RIGHTS					
14. ABSTRACT The Purpose of this figure study was to demonstrate the optical figure and opto-mechanical performance capabilities for Trex's CVC SiC material. In the course of this activity a plano mirror was designed, fabricated, polished, and analyzed using interferometry tools and methods. The opto-mechanical and interferometric performance results are presented and analyzed in this report.					
15. SUBJECT TERMS					
16. SECURITY CLASSIFICATION OF: a. REPORT Unclassified			17. LIMITATION OF ABSTRACT SAR	18. NUMBER OF PAGES 23	19a. NAME OF RESPONSIBLE PERSON Ryan Conk
b. ABSTRACT Unclassified					19b. TELEPHONE NUMBER (include area code)
c. THIS PAGE Unclassified					



Chemical Vapor Composite Silicon Carbide for Space Telescopes

AFRL Phase 2 SBIR

Clifford T. Tanaka / Kyle Webb

Trex Enterprises Corporation

Chemical Vapor Composite Silicon Carbide for Space Telescopes

ACKNOWLEDGEMENTS

- ◆ Work supported by AFRL/DE
- ◆ Thanks to:
 - General Optics for optical metrology.
 - 3D-Engineering Corp. for Finite Element Analysis.
 - ATA Engineering Corp. for modal testing.
 - Ormond, LLC for water jet milling.

Chemical Vapor Composite Silicon Carbide for Space Telescopes

Overview

- ◆ **Goal: Produce a 750mm aperture CVC SiC mirror for the Advanced Relay Mirror System (ARMS)**

- ◆ **Tasks:**

- 150mm CVC SiC Plano Mirror Figure Study
 - Demonstrate fabrication of a stiff, high quality lightweighted mirror
 - Compare modeled FEA modal performance vs. experimental measurements
- Evaluation of HEL coatings on CVC SiC coupons
- 750 mm CVC SiC mirror design & fabrication

- ◆ **Status:**

- 150 cm CVC SiC Mirror analysis completed.
- HEL coating evaluation underway.
- 750 mm CVC SiC mirror design completed. Fabrication in 2007.

Chemical Vapor Composite Silicon Carbide for Space Telescopes 150mm CVC SiC Plano Mirror Figure Study

- ◆ The purpose of this figure study was to demonstrate the optical figure and opto-mechanical performance capabilities for Trex's CVC SiC material.
- ◆ In the course of this activity a plano mirror was designed, fabricated, polished, and analyzed using interferometry tools and methods.
- ◆ The opto-mechanical and interferometric performance results are presented and analyzed in this report.

Chemical Vapor Composite Silicon Carbide for Space Telescopes 150mm CVC SiC Piano Mirror

- ◆ The following specifications were established to benchmark the optical and opto-mechanical performance in this effort:

- Surface Figure:
 - Plano surface: 150mm outside diameter with a 95% clear aperture
 - Peak to Valley reflected wave front error: $< \lambda/10$ at 632.8 nm
- Surface Roughness: $< 20 \text{ \AA rms}$.
- Areal Density: $</= 10 \text{ kg/m}^2$
- Modal Frequency Specification: $>/= 1500 \text{ Hz}$ in free-state
- Ultra-Light-Weight, Open Back, Iso-Grid Mechanical Configuration: $</= 200 \text{ grams}$

- ◆ Design Approach:

- Finite Element Analysis (FEA) tools were used extensively to formulate an aggressive opto-mechanical design that would test the limits of the CVC SiC material as it is applied to challenging optical figure polishing processes.
- Sensitivities associate with self-weight-sag and print-through or quilting were anticipated to be revealed and studied.

Chemical Vapor Composite Silicon Carbide for Space Telescopes

150mm CVC SiC Piano Mirror

150mm Mirror Detailed Design (sheet 1 of 2)

NOTES UNLESS OTHERWISE SPECIFIED		SPECIFICATIONS		DRAWING	
REF ID:	REV:	REF ID:	REV:	REF ID:	REV:
1. APPENDIX STANDARDS/SPECIFICATIONS A. ASME Y14.5M-1994 (DIMENSIONS AND TOLERANCES) B. 4.5.2-REVISION 1A TEST REVISION 1 FOR VARIOUS OPERATIONS		REF ID: E1000 REV: C1000 UPDATED 10/15/05		REF ID: D2712005 REV: 7/11/2005	
2. MATERIAL TYPE: CVC SC					
3. WEDGE = 1 ARC MINUTE					
4. CHAMFER ALL EDGES TO 0.05±0.010 X 45°±1°					
5. CLEAR APERTURE MIN 5% OF OD					
6. SPOT SIZE 40-50 OR BETTER PER MILPRF-2830 OVER CLEAR APERTURE					
7. EDGE CHAMFER TO BE SMOOTH AND NOT ENTERED TOWARD BEYOND 1.0					
8. SURFACES ARE TO BE FREE OF GROUND					
9. SURFACE = PLAIN					
10. REACTO-VAPORLESS REFLECTED WAVEFRONT ERROR < 1/10 AT 632.8 nm SURFACE ROUGHNESS < 20 ANGSTROMS RMS OVER CLEAR APERTURE					
11. COATING = TD R=99.9% AT 1.054 MICRONS					
12. DIFFERENT ACTIVE COATING SURFACE AS "V" APPROXIMATE WHERE SHOWN USING NO PARTICLE GENERATING INORGANIC MARKING MATERIAL					
13. IDENTIFY WITH THREE PART NUMBER, NUMBER AND ID NUMBER APPROXIMATE WHERE SHOWN USING NO PARTICLE GENERATING INORGANIC MATERIAL. TEXT MUST BE CLEAR AND EASILY READABLE WITHOUT MAGIFICATION					
14. COATING QUALITY NUMBER (X) WHERE X = CHAMBER ID (E.G. A=1, B=2, ETC. 4 ID # = UNIQUE BUILD NUMBER = MOLD NUMBER C = MATERIAL LOT ID NUMBER)					
15. CLEAR PART AND PACKAGE USING CERAMIC OUTGASSING, PARTICLE FREE MATERIAL, NO CERAMIC CAVITY, NO DOUBLE BAG PACKAGING OPTICS TO BE PACKAGED SUCH THAT NO MATERIAL INCLUDING LENS/TISSUE CONTACTS THE OPTIC WITHIN THE CLEAR APERTURE					
16. PART TO BE PACKAGED IN INDIVIDUAL AND LABELED ON THE OUTER SURFACE OF THE PACKAGE WITH THREE PART NUMBER AND CODE NUMBER THE SAME AS IN NOTE 12					
17. THE FOLLOWING DOCUMENT MUST BE SUPPLIED FOR EACH SERIALIZED PART (ELECTRONICALLY DATA STORED IN A DOBLE-BAG PACKAGE) FOR EACH COATING GRU.					
18. MANUFACTURING METHODS EQUIPMENT AND MATERIALS THAT ARE USED TO FABRICATE THIS PART ARE NOT TO BE CHANGED AFTER THREE QUALIFICATIONS.					
19. THREE (3) COATINGS ARE TO BE APPLIED					

Chemical Vapor Composite Silicon Carbide for Space Telescopes

150mm CVC SiC Piano Mirror

150mm Mirror Detailed Design (sheet 2 of 2)

Face Sheet Thickness:

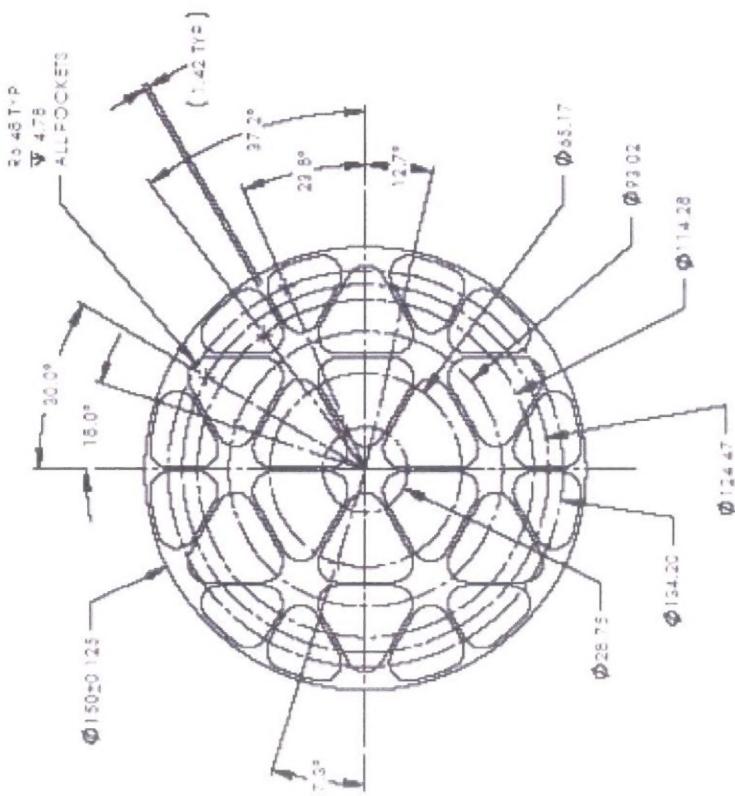
$$6.35\text{mm} - 4.78\text{mm} = 1.57\text{mm}$$

Aspect Ratio:

$$6.35\text{mm}/150\text{mm} = .0423$$

(23.62 to 1)

Mass: 155gr



Chemical Vapor Composite Silicon Carbide for Space Telescopes

150mm CVC SiC Plano Mirror

Interferometer Measurement Configurations

♦ **Horizontal:**

- Three Point Supported at Iso-Grid Nodes
- Supported on Tissue Paper
- Supported at center Iso-grid Node
- Three Point support at Mirror Edge

♦ **Vertical:**

- Edge mounted on a V block
- Edge mounted on a V block and rotated from original measured position.
- Edge mounted on a V block and rotated again from the last measured position.

Chemical Vapor Composite Silicon Carbide for Space Telescopes

150mm CVC SiC Piano Mirror

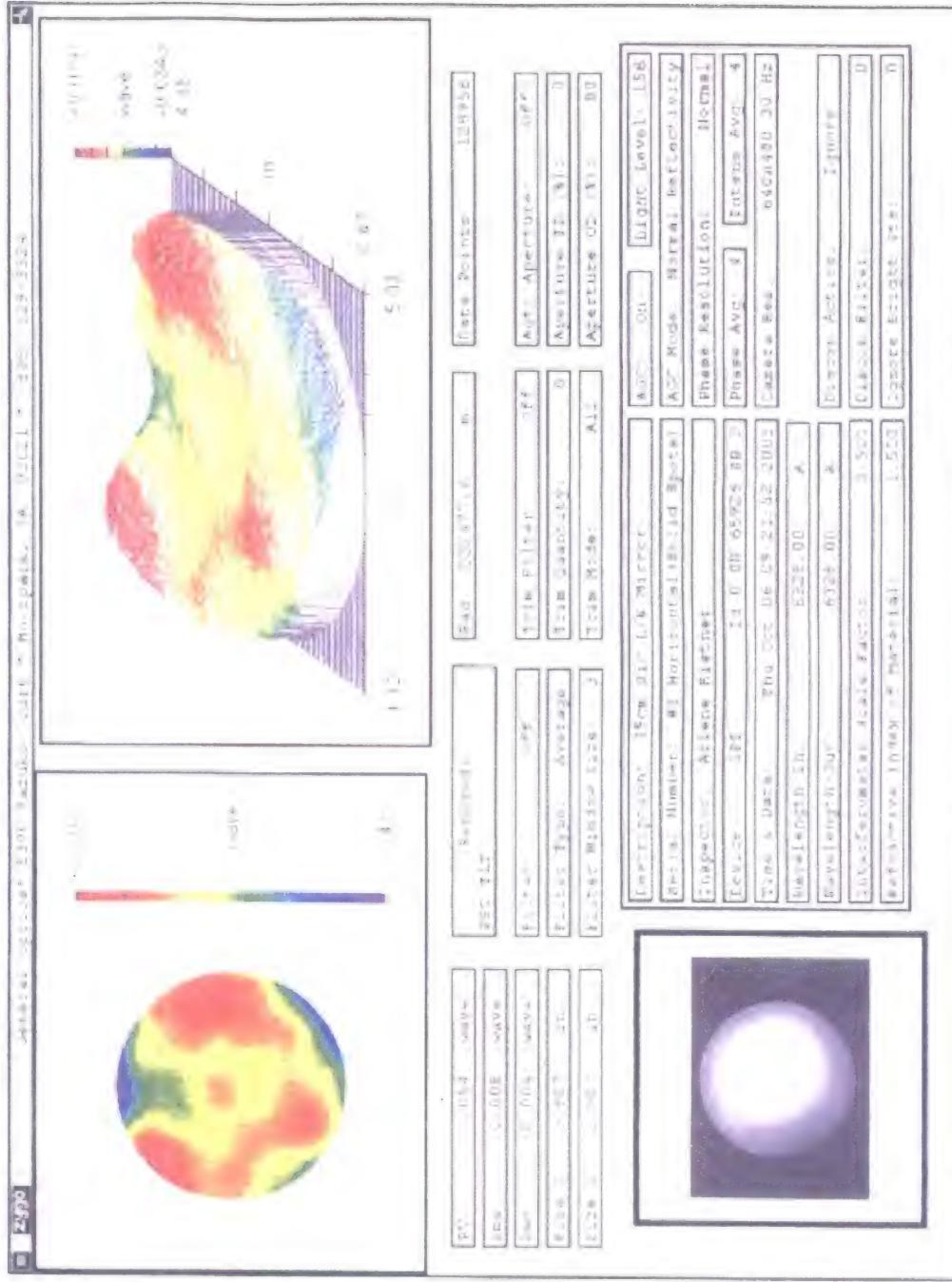
Horizontal, Three Point Support at Iso-Grid Nodes

Interferometer Performance:

- pv 0.054 waves ($\lambda/19$)
- rms 0.008 waves ($\lambda/125$)
- Pwr -0.004 waves

Measurement Orientation:

- Horizontal (flat on optical table)
- Mirror supported from point contacts on 3 iso-grid nodes
- Produces best results on interferogram for this mounting orientation.



Three point support on iso-grid nodes

Chemical Vapor Composite Silicon Carbide for Space Telescopes

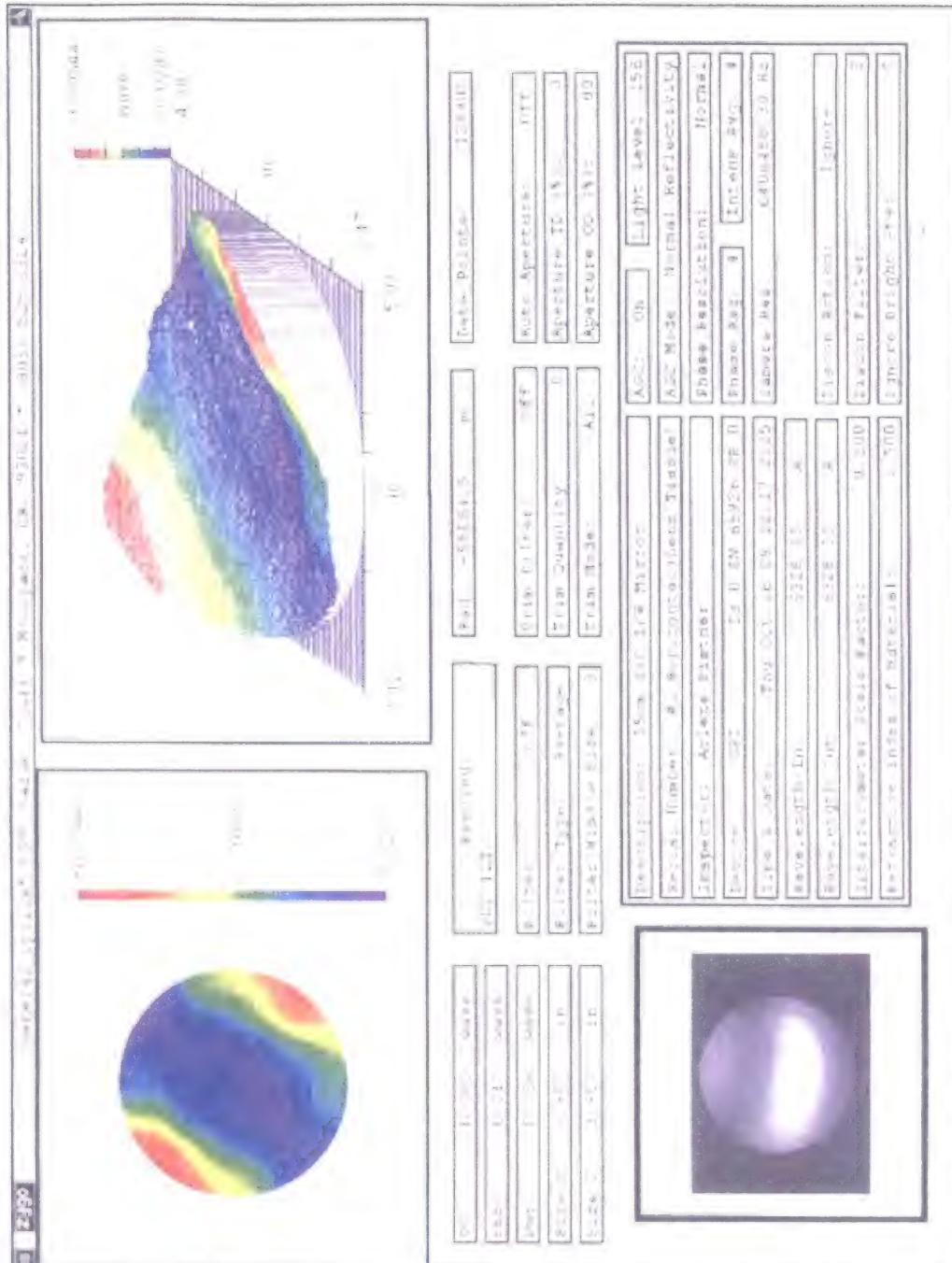
150mm CV/C SiC Plane Mirror Horizontal, Mounted on Tissue Paper

Interferometer Performance:

- pV 0.083 waves ($\lambda/12$)
- Rms 0.017 waves ($\lambda/59$)
- Pwr 0.034 waves

Measurement Orientation:

- Horizontal (flat on optical table)
- Mirror supported with tissue paper only.
- Produces classic potato chip shape interferogram.



Tissue Paper Support

Chemical Vapor Composite Silicon Carbide for Space Telescopes

150mm CVC SiC Piano Mirror

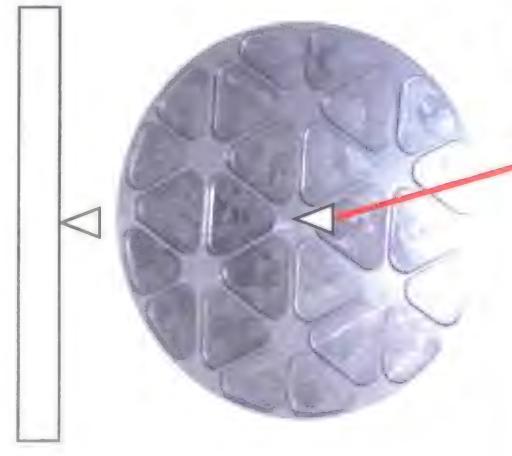
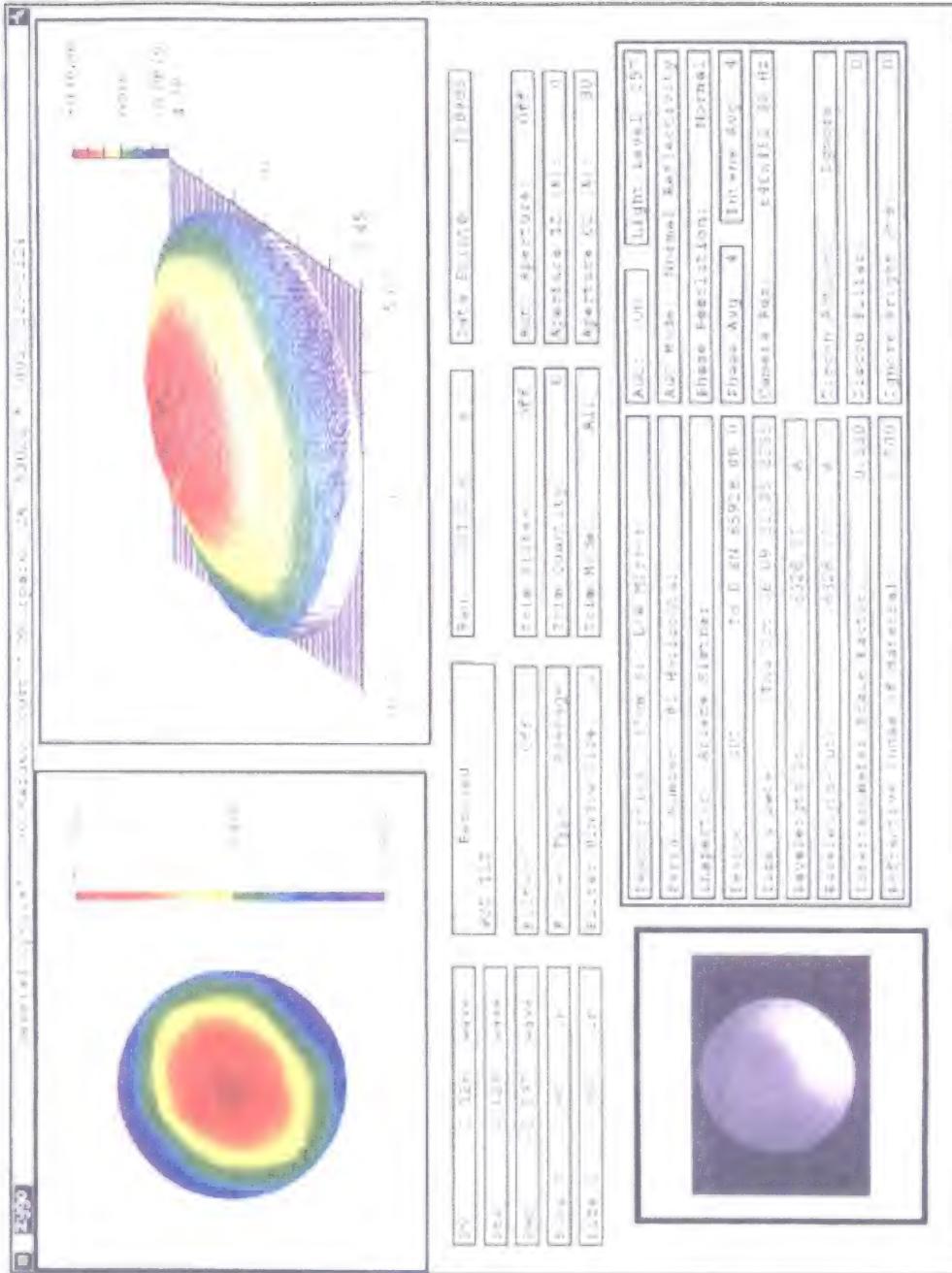
Horizontal Mount, Single Flat Contact Point at Center

Interferometer Performance:

- pV 0.126 waves ($\lambda/8$)
- rms 0.029 waves ($\lambda/34$)
- Pwr -0.097 waves

Measurement Orientation:

- Horizontal (flat on optical table)
- Mirror supported at the center iso-grid node flat on the back side only.
- Produces a convex shape as seen in the interferogram.



Single flat contact support at center Iso-grid node

Chemical Vapor Composite Silicon Carbide for Space Telescopes

150mm CVC SiC Piano Mirror

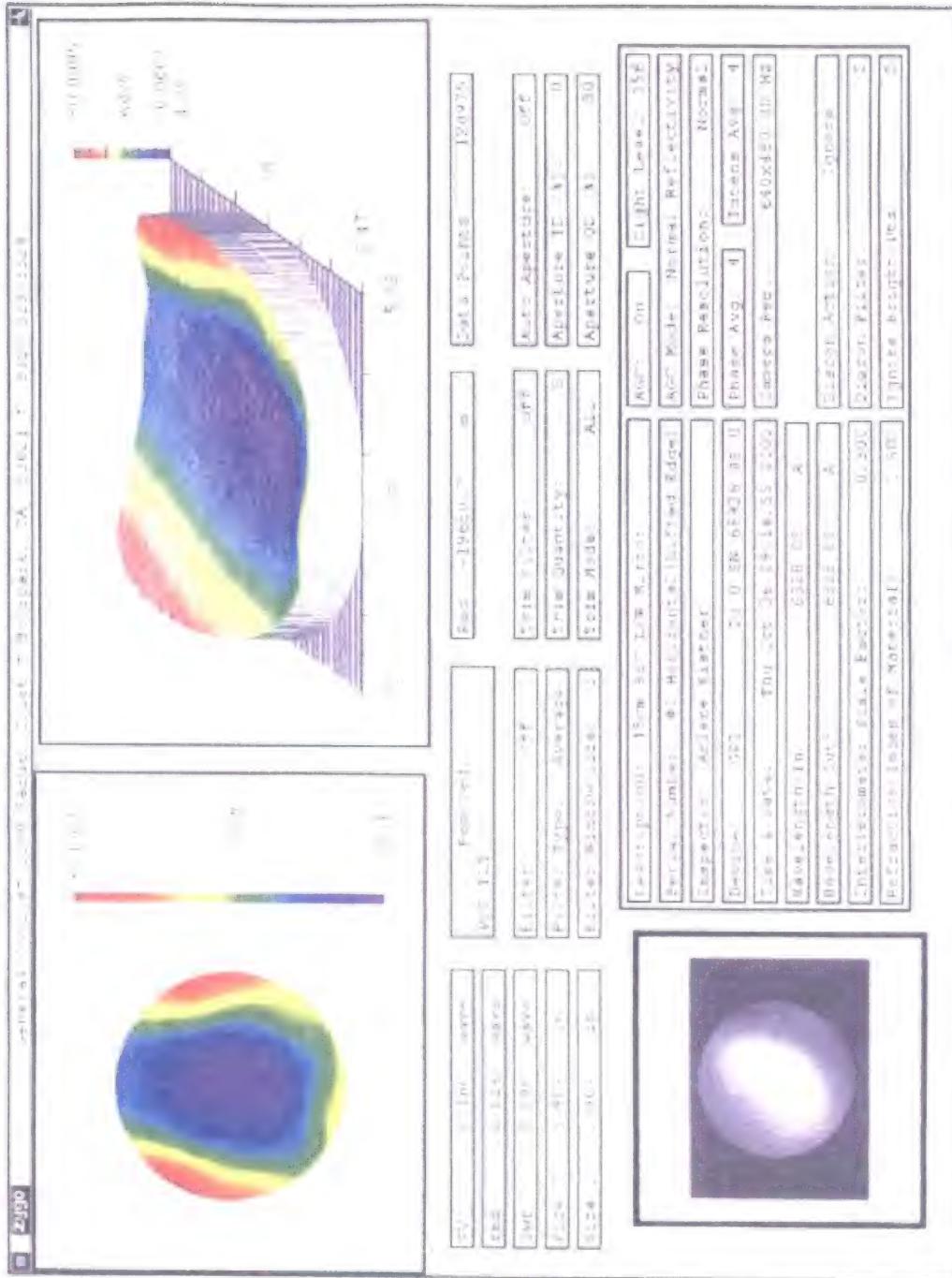
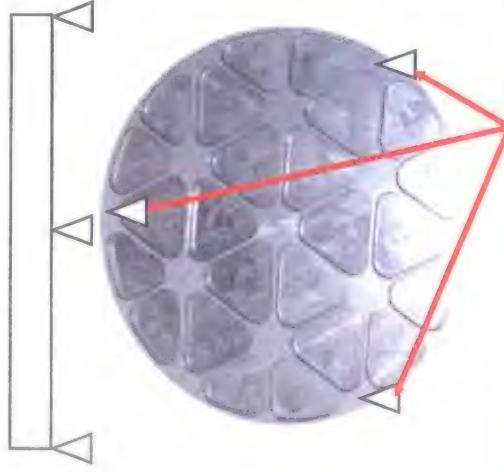
Horizontal Mount, Three Point Support at Edge

Interferometer Performance:

- pV 0.160 waves ($\lambda/6$)
- rms 0.034 waves ($\lambda/29$)
- Pwr 0.099 waves

Measurement Orientation:

- Horizontal (flat on optical table)
- Mirror supported with 3 point contacts at perimeter edge
- Produces lifted edge or concave profile on interferogram.



Three point edge support configuration

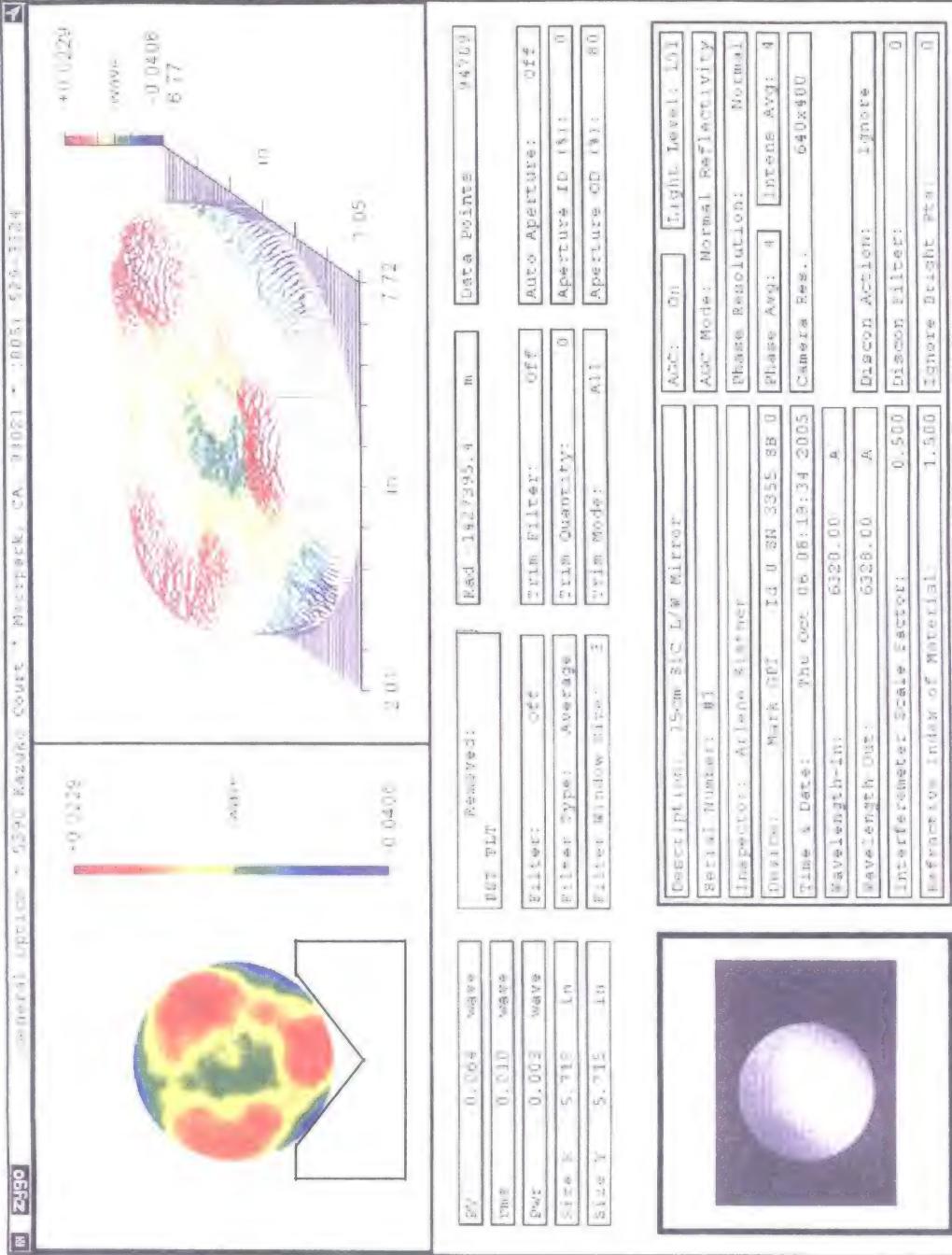
Chemical Vapor Composite Silicon Carbide for Space Telescopes

150mm CVC SiC Plane Mirror Vertical Mount, V-Block

6
TELESCOPE

Interferometer Performance:

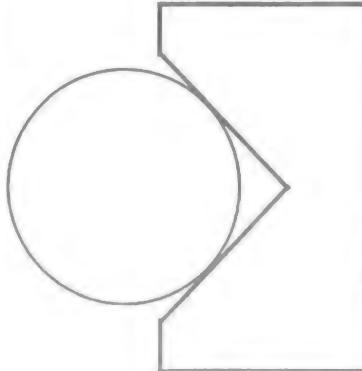
- p.v. 0.064 waves ($\lambda/16$)
- rms 0.010 waves ($\lambda/100$)
- Pwr 0.003 waves



Measurement Orientation:

- Vertical (V-Block support)
- V-Block oriented in normal configuration as viewed in interferograms.

Produces best results on interferogram for this mounting orientation.



Chemical Vapor Composite Silicon Carbide for Space Telescopes

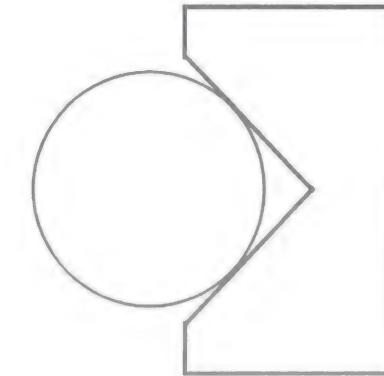
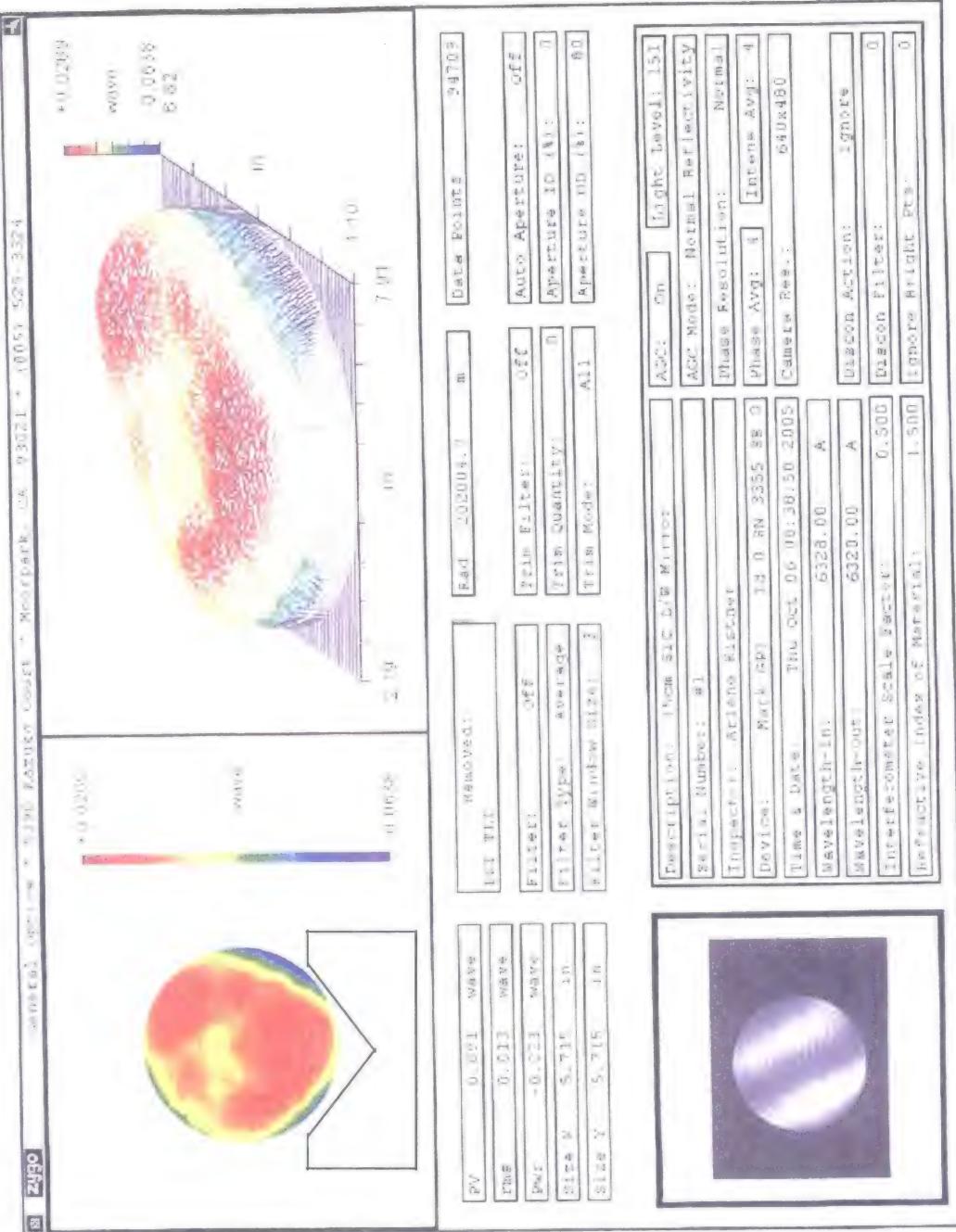
150mm CVC SiC Piano Mirror Vertical Mount, V-Block (rotated)

Interferometer Performance:

- pv 0.091 waves ($\lambda/11$)
- rms 0.013 waves ($\lambda/77$)
- Pwr -0.021 waves

Measurement Orientation:

- Vertical (V-Block support)
- V-Block oriented in normal configuration as viewed in interferograms.
- Rotated from previous position.



Telescope Location:	15cm SiC Piano Mirror	Avg:	0.07	Light Length:	151
Serial Number:	#1	AGC Mode:	Normal Reflectivity	Normal Resolution:	Normal
Filter Quality:	Attenuation Radiane	Phase Resolution:	0.025	Camera Res.:	None
Day/Date:	W/14 (2005)	Time & Date:	13 Oct 06 08:38:50 2005	Phase Avg.:	4
Wavelength-nm:	6328.00	Camera Res.:	640x480	Diagonal Resolution:	2.5nm
Masking/Filter:	6328.00	Phase Lock:		Diagonal Filter:	0
Interferometer Type:	Scalable Sagnac	Scalable:	0.500	Diagonal Height Err.:	0
Interferometer Material:	1.500	Diagonal Height Err.:	0		

Chemical Vapor Composite Silicon Carbide for Space Telescopes

150mm CVC SiC Plane Mirror

Vertical Mount, V-Block (rotated again)

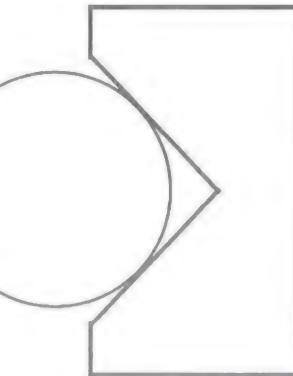
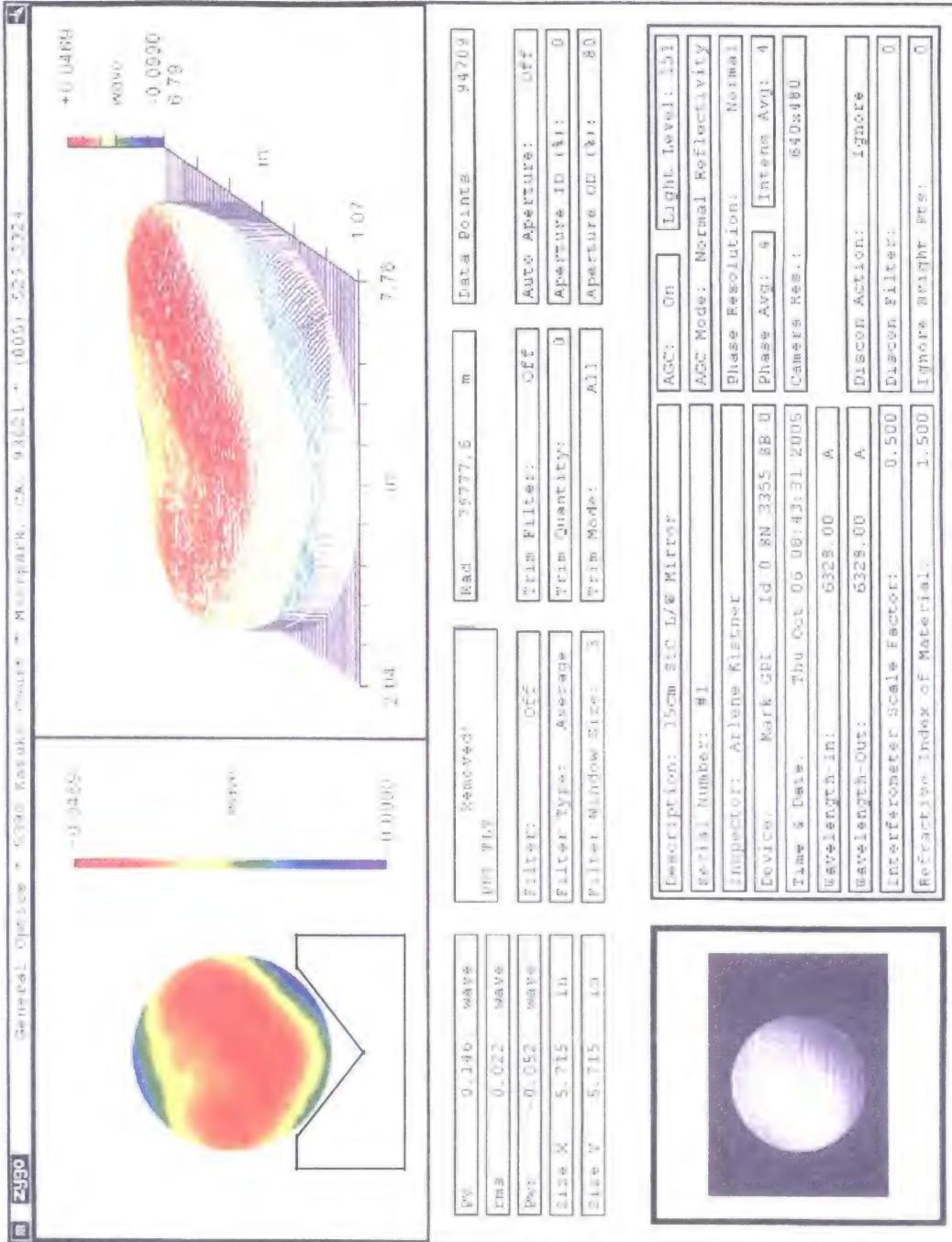
Interferometer Performance:

- pV 0.146 waves ($\lambda/7$)
- rms 0.022 waves ($\lambda/45$)
- Pwr -0.052 waves

Measurement Orientation:

- Vertical (V-Block support)
- V-Block oriented in normal configuration as viewed in interferograms.

- Rotated again from previous position.

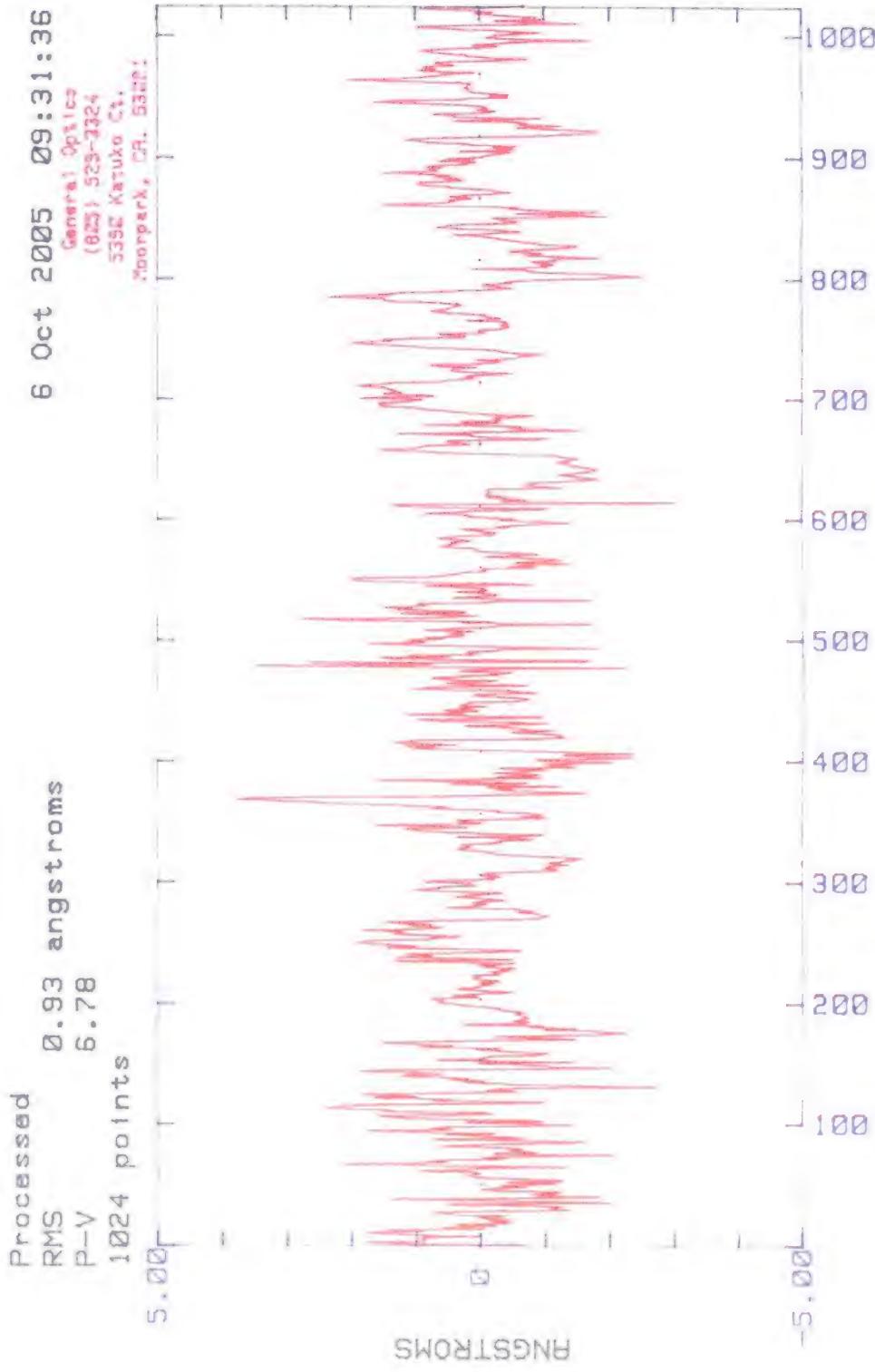


Chemical Vapor Composite Silicon Carbide for Space Telescopes

150mm CVC SiC Piano Mirror Surface Roughness via Zygo



15cm SiC L/W Mirror #1



Chemical Vapor Composite Silicon Carbide for Space Telescopes 150mm CVC SiC Plane Mirror Modal Analysis

- ◆ Test was perform via classical ping test protocol.

- Foam bed used to simulate free state mode.
- Tiny hammer accelerometer & response accelerometer.
- Ping responses were collected from nine (9) points depicted in schematic (in figure at right).
- Software program transformed responses into wire plots of mode shapes as presented in earlier slides

- ◆ Comparison made to Finite Element Analysis Results



Wire Frame Schematic of
Ping Test Points on Mirror



Hammer Accelerometer Shown as Tested

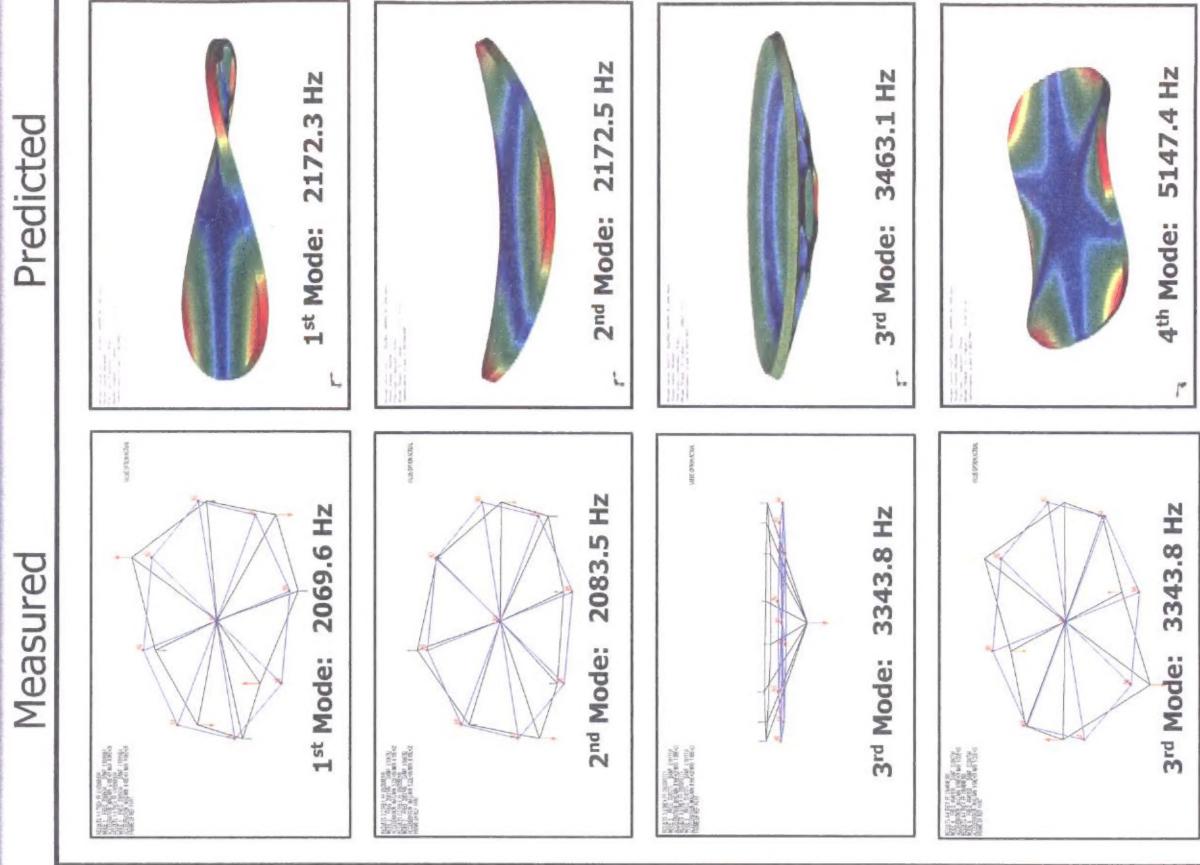


Test Setup Showing Foam Bed & Tiny Hammer Accelerometer

Chemical Vapor Composite Silicon Carbide for Space Telescopes

150mm CVC SiC Plano Mirror Modal Analysis Results

- ♦ A close correlation is established between the predicted modal values and the actual measured modal values
- ♦ Variance in higher modes can be attributed to:
 - Difference between theory and reality.
 - Constraint conditions in FEA model can not exactly duplicate actual constraint system as tested (foam bed).



		Measured		
Predicted	Mode	Hz	Mode	Hz
1st	2172.3	1st	2069.6	
2nd	2172.5	2nd	2083.5	
3rd	3463.1	3rd	3343.8	
4th	5464.1	4th	4646.9	

Chemical Vapor Composite Silicon Carbide for Space Telescopes

150mm CVC SiC Plano Mirror

Water Jet Cutting of CVC SiC

- ◆ Development of water jet cutting and milling process have proven to be feasibility for fabrication:

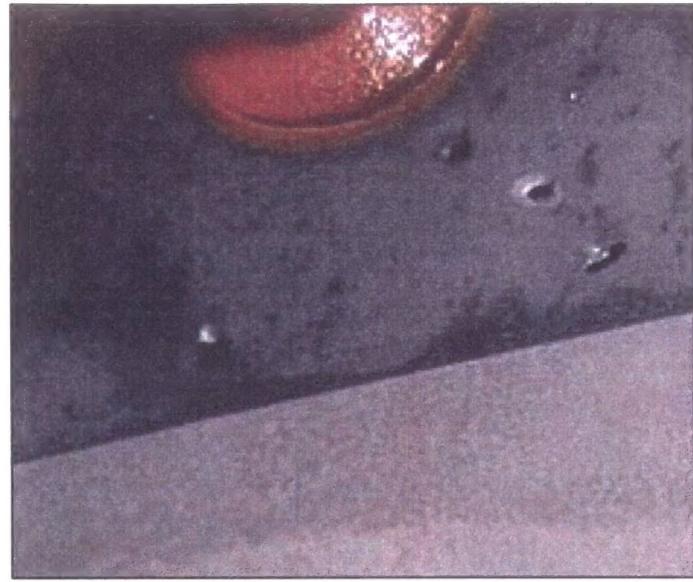
- Demonstrated Water Jet Cutting and Piercing Processes:



Initial Water Jet Piercing
Through .5" of CVC SiC
Material



Water Jet Piercing
Through 1.3" of CVC
SiC Material



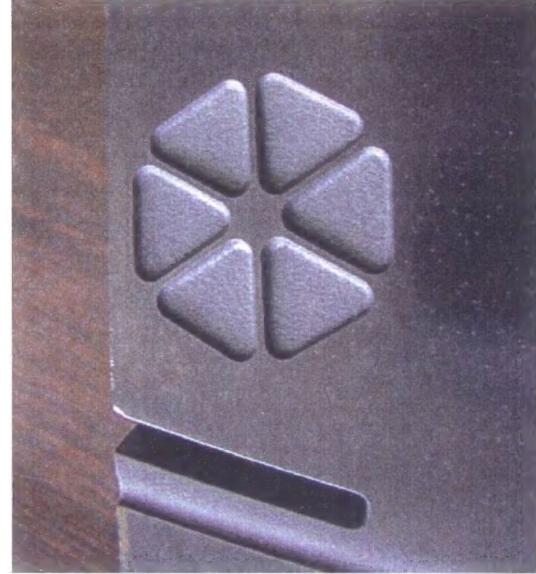
Water Jet Cutting Through
1.3" of CVC SiC Material

Chemical Vapor Composite Silicon Carbide for Space Telescopes

150mm CVC SiC Plano Mirror
Water Jet Milling of CVC SiC

◆ 5 Axis water jet milling capability has been established:

- Demonstrated water jet milling process:
 - Current process produces punch through of 1.3" thick CVC SiC material in 40 seconds
 - Cutting rates of over 1 linear inch per minute on 1.3" material have been demonstrated.
 - Milling rates of .010" per pass have been demonstrated.



Water Jet Milling Simple Masking Setup

Water Milling of 25mm by 25mm Square by 4mm Deep Pocket in CVC SiC Material

Water Milling of Isogrid for lightweighting of CVC SiC

Chemical Vapor Composite Silicon Carbide for Space Telescopes

Summary

- ◆ CVC Silicon Carbide is an ideal optical material, with high specific stiffness, superior thermal stability, polishability and low residual stress.
- ◆ 15cm plano CVC SiC mirror with excellent stiffness, surface figure and surface roughness has been demonstrated.
- ◆ Experimental and theoretical modal analysis show that CVC SiC components can be readily designed & modeled.
- ◆ Trex is proceeding with 750mm aperture mirror fabrication, to be completed in 2007.